

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant : Takeshita et al.  
Appl. No. : 10/580,768  
Filed : May 25, 2006  
For : POSITIVE RESIST  
COMPOSITION AND METHOD  
FOR FORMING RESIST  
PATTERN  
Examiner : Eoff, A.  
Group Art Unit : 1795

**CERTIFICATE OF EFS WEB  
TRANSMISSION**

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8/20/08

(Date)

Neil S. Bartfeld, Ph.D., Reg. No. 39,901

**AMENDMENT AND RESPONSE TO OFFICE ACTION****Mail Stop Amendment**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action mailed **May 23, 2008**, please consider the following  
remarks:

**Amendments to the claims** are reflected in the listing of claims which begins on page 2  
of this paper.

**Remarks** begin on page 6 of this paper.